



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#5/A
(13)
10/9/02

Applicant: Howard M. Branz) Examiner: Umez Eronini, Lynette T.
Serial No.: 09/714,331) Art Unit: 1765
Filed: November 16, 2000)
Title: Method for Improving the) Docket No.: NREL 99-10
Stability of Amorphous)
Silicon)

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AMENDMENT

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

This Amendment is responsive to the outstanding Office Action mailed June 5, 2002. No fee is believed to be necessary. However, should any fee be required for entry of this paper, the Commissioner is authorized to charge our Deposit Account 14-0460 and is requested to notify us of the same.

Please amend the application as follows:

IN THE CLAIMS

Please cancel claim 7.

Please amend the following claims:

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Sub B1
A1
1. (Once Amended) A method of producing a stabilized amorphous silicon film, comprising the steps of:

- (a) providing an amorphous silicon film deposited on to a substrate, the film having an exposed surface;
- (b) illuminating the film with an essentially blue or ultraviolet light to form a light damaged region and a stabilized region; and
- (c) etching the light damaged region to expose a portion of the stabilized region.